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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:

Ju-Cheol SHIN, et al.

Serial No. 10/678,184

Filed: October 6, 2003

For: METAL INTERCONNECTION WITH LOW RESISTANCE IN A SEMICONDUCTOR DEVICE (As Amended)

Group Art Unit: 2823

Examiner: Fernando L. Toledo

Confirmation No. 2334

Atty. Docket No. 262/016 DIV

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office action dated June 14, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in a listing of claims, which begins on page 4 of this paper.

Remarks begin on page 10 of this paper.

A replacement Abstract of the Disclosure is attached at page 17 of this paper.

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